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<u>"</u> L1	36468	ALD (atomic adj layer\$1 adj deposit\$5)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/06 14:59
L2	341	1 and (("TiCl.sub.4" (trimethyl adj aluminum)) same ("NH.sub.3" ozone))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/06 15:01
L3	11	2 and (mono adj layer\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/06 15:28
L4	117	1 and (mono adj layer\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/06 15:03
L5	48	4 and purg\$3 with (chamber\$1 reactor\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/06 15:07

Interference Search

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L7	2	((mono adj layer\$1) same pulse\$1). clm.	US-PGPUB	OR	OFF	2006/01/06 15:30



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Day: Friday Date: 1/6/2006 Time: 15:32:14

Inventor Name Search Result

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Last Name = MARSH First Name = EUGENE

Application#	Patent#	Status	Date Filed	Title	Inventor Name
10229887	6673701	150	1	ATOMIC LAYER DEPOSITION METHODS	MARSH, EUGENE
10734999	Not Issued	71		Deposition methods with time spaced and time abutting precursor pulses	MARSH, EUGENE
11217949	Not Issued	20	09/01/2005	Atomic layer deposition systems and methods including silicon-containing tantalum precursor compounds	MARSH, EUGENE
07534891	5050296	150	06/07/1990	AFFIXING PLUGGABLE PINS TO A CERAMIC SUBSTRATE	MARSH, EUGENE L.
06473570	4625850	150	03/09/1983	PRESS CLUTCH CONTROL SYSTEM	MARSH, EUGENE M.
09506962	<u>6541067</u>	150	02/18/2000	SOLVATED RUTHENIUM PRECURSORS FOR DIRECT LIQUID INJECTION OF RUTHENIUM AND RUTHENIUM OXIDE AND METHOD OF USING SAME	MARSH, EUGENE P
09651859	6461909	150	08/30/2000	PROCESS FOR FABRICATING RUSIXOY-CONTAINING ADHESION LAYERS	MARSH, EUGENE P
<u>09146556</u>	6271131	150	09/03/1998	METHODS FOR FORMING RHODIUM- CONTAINING LAYERS SUCH AS PLATINUM-RHODIUM BARRIER LAYERS	MARSH, EUGENE P
09489783	6143085	150	01/24/2000	Laser desorption of cvd precursor species	MARSH, EUGENE P.
09491967	6187392	150	01/27/2000	Laser desorption of CVD precursor species	MARSH, EUGENE P.
09505333	6271519	150		Analysis of semiconductor surfaces by secondary ion mass spectrometry	MARSH, EUGENE P.
09542429	6626999	150	04/04/2000	VAPOR FORMING DEVICES, AND METHODS OF CLEANING VAPORIZATION SURFACES	MARSH, EUGENE P.
<u>09542796</u>	6419994	150	04/04/2000	METHODS OF CHEMICAL VAPOR	MARSH, EUGENE P.

		ĺ		DEPOSITION	
09571718	6342445	150	05/15/2000	Method of fabricating an SrRuO3 Film	MARSH, EUGENE P.
09573034	6281125	150	05/17/2000	Methods for preparing ruthenium oxide films	MARSH, EUGENE P.
09594171	Not Issued	161	06/15/2000	Oxidation Resistant Platinum Film For Capacitors	MARSH, EUGENE P.
09594339	6387802	150	II s	Nucleation and deposition of PT films using ultraviolet irradiation	MARSH, EUGENE P.
09603132	Not Issued	71		Device structures including ruthenium silicide diffusion barrier layers	MARSH, EUGENE P.
09651620	6903005	150		METHOD FOR THE FORMATION OF RUSIXOY-CONTAINING BARRIER LAYERS FOR HIGH-K DIELECTRICS	MARSH, EUGENE P.
09651699	6690055	150	III III	DEVICES CONTAINING PLATINUM- RHODIUM LAYERS AND METHODS	MARSH, EUGENE P.
09652636	6660631	150	08/31/2000	DEVICES CONTAINING PLATINUM- IRIDIUM FILMS AND METHODS OF PREPARING SUCH FILMS AND DEVICES	MARSH, EUGENE P.
09653513	6642567	150	08/31/2000	DEVICES CONTAINING ZIRCONIUM- PLATINUM-CONTAINING MATERIALS AND METHODS FOR PREPARING SUCH MATERIALS AND DEVICES	MARSH, EUGENE P.
09680246	6312557	150		Method and apparatus for using photoemission to determine the endpoint of an etch process	MARSH, EUGENE P.
09790405	6403499	150	02/21/2001	PLANARIZATION OF NON-PLANAR SURFACES IN DEVICE FABRICATION	MARSH, EUGENE P.
09795999	6528786	150	02/28/2001	ANALYSIS OF SEMICONDUCTOR SURFACES BY SECONDARY ION MASS SPECTROMETRY AND METHODS	MARSH, EUGENE P.
09812157	6858535	150	II I	METHODS FOR PATTERNING METAL LAYERS FOR USE WITH FORMING SEMICONDUCTOR DEVICES	MARSH, EUGENE P.
09855532	Not Issued	95		METHOD OF FORMING MIRRORS BY SURFACE TRANSFORMATION OF EMPTY SPACES IN SOLID STATE MATERIALS AND STRUCTURES THEREON	MARSH, EUGENE P.
09884997	6656835	150	11 1	PROCESS FOR LOW TEMPERATURE ATOMIC LAYER DEPOSITION OF RH	MARSH, EUGENE P.

09886332	6455423	150	06/21/2001	DIRECT WRITING OF LOW CARBON CONDUCTIVE MATERIAL	MARSH, EUGENE P.
<u>09888891</u>	6462367	150	06/25/2001	RUSIXOY-CONTAINING ADHESION LAYERS	MARSH, EUGENE P.
09891919	6429439	150	06/26/2001	ORGANIC FIELD IONIZATION SOURCE	MARSH, EUGENE P.
09923662	6403414	150	08/07/2001	METHOD FOR PRODUCING LOW CARBON/OXYGEN CONDUCTIVE LAYERS	MARSH, EUGENE P.
09923851	6495458	150	08/07/2001	METHOD FOR PRODUCING LOW CARBON/OXYGEN CONDUCTIVE LAYERS	MARSH, EUGENE P.
09935465	6796313	150	08/21/2001	METHODS OF CLEANING VAPORIZATION SURFACES	MARSH, EUGENE P.
09935490	6610568	150	08/23/2001	PROCESS FOR FABRICATING RUSIXOY-CONTAINING ADHESION LAYERS	MARSH, EUGENE P.
09942200	Not Issued	61		DIFFUSION BARRIER LAYERS AND METHODS OF FORMING SAME	MARSH, EUGENE P.
09945393	Not Issued	71	II 3	Dielectric material forming methods and enhanced dielectric materials	MARSH, EUGENE P.
10003261	6506666	150	12/06/2001	METHOD OF FABRICATING AN SRRUO3 FILM	MARSH, EUGENE P.
10012668	6517616	150		SOLVATED RUTHENIUM PRECURSORS FOR DIRECT LIQUID INJECTION OFRUTHENIUM AND RUTHENIUM OXIDE	MARSH, EUGENE P.
10075574	6737317	150		METHOD OF MANUFACTURING A CAPACITOR HAVING RUSIXOY- CONTAINING ADHESION LAYERS	MARSH, EUGENE P.
10075819	6617634	150	02/12/2002	A CAPACITOR HAVING RUSIXOY- CONTAINING ADHESION LAYERS	MARSH, EUGENE P.
10075863	6800937	150		RUSIXOY-CONTAINING ADHESION LAYERS	MARSH, EUGENE P.
10133951	Not Issued	61	III III	Metal layer forming methods and capacitor electrode forming methods	MARSH, EUGENE P.
10136771	6744138	150	11	PROCESS FOR THE FORMATION OF RUSIXOY-CONTAINING BARRIER LAYERS FOR HIGH-K DIELECTRICS	MARSH, EUGENE P.
10157376	6569689	150	05/29/2002	METHOD OF FORMING A CAPACITOR	MARSH, EUGENE P.
10158978	6764895	150	05/30/2002	PROCESS FOR FABRICATING RUSIXOY-CONTAINING ADHESION LAYERS	MARSH, EUGENE P.

10165263	6677252	150		METHODS FOR PLANARIZATION OF NON-PLANAR SURFACES IN DEVICE FABRICATION	MARSH, EUGENE P.
10179946	6881260	150		PROCESS FOR DIRECT DEPOSITION OF ALD RHO2	MARSH, EUGENE P.
10215990	6800521	150		PROCESS FOR THE FORMATION OF RUSIXOY-CONTAINING BARRIER LAYERS FOR HIGH-K DIELECTRICS	MARSH, EUGENE P.
10215991	6787449	150	08/09/2002	PROCESS FOR THE FORMATION OF RUSIXOY-CONTAINING BARRIER LAYERS FOR HIGH-K DIELECTRICS	MARSH, EUGENE P.

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Application#	Patent#	Status	Date Filed	Title	Inventor Name
10230605	6830983	150	08/29/2002	PLATINUM STUFFED WITH SILICON OXIDE AS A DIFFUSION OXYGEN BARRIER FOR SEMICONDUCTOR DEVICES	MARSH, EUGENE P.
10231434	6783657	150	08/29/2002	SYSTEMS AND METHODS FOR THE ELECTROLYTIC REMOVAL OF METALS FROM SUBSTRATES	MARSH, EUGENE P.
10231435	6861355	150	08/29/2002	METAL PLATING USING SEED FILM	MARSH, EUGENE P.
10232215	Not Issued	41	08/29/2002	Systems for electrolytic removal of metals from substrates	MARSH, EUGENE P.
10283316	6943073	150	10/30/2002	PROCESS FOR LOW TEMPERATURE ATOMIC LAYER DEPOSITION OF RH	MARSH, EUGENE P.
10303017	6813136	150	11/25/2002	MEMORY STRUCTURE WITH AN ANNEALED FILM	MARSH, EUGENE P.
10322264	6844261	150	12/17/2002	SOLVATED RUTHENIUM PRECURSORS FOR DIRECT LIQUID INJECTION OF RUTHENIUM AND RUTHENIUM OXIDE	MARSH, EUGENE P.
10358939	6855928	150	02/04/2003	ANALYSIS OF SEMICONDUCTOR SURFACES BY SECONDARY ION MASS SPECTROMETRY AND METHODS	MARSH, EUGENE P.
10365204	6840988	150		SOLVATED RUTHENIUM PRECURSORS FOR DIRECT LIQUID INJECTION OF RUTHENIUM AND RUTHENIUM OXIDE	MARSH, EUGENE P.
10392047	<u>6884691</u>	150		METHOD OF FORMING A SUBSTRATE HAVING A SURFACE COMPRISING AT LEAST ONE OF PT, PD, CO AND AU IN AT LEAST ONE OF ELEMENTAL AND ALLOY FORMS	MARSH, EUGENE P.
10413750	6757153	150		THIN FILM STRUCTURE THAT MAY BE USED WITH AN ADHESION	MARSH, EUGENE P.

				LAYER	
10418411	6737313	150	04/16/2003	SURFACE TREATMENT OF AN OXIDE LAYER TO ENHANCE ADHESION OF A RUTHENIUM METAL LAYER	MARSH, EUGENE P.
10430456	6867093	150	05/06/2003	PROCESS FOR FABRICATING RUSIXOY-CONTAINING ADHESION LAYERS	MARSH, EUGENE P.
10430457	6867449	150	05/06/2003	CAPACITOR HAVING RUSIXOY- CONTAINING ADHESION LAYERS	MARSH, EUGENE P.
10440587	6713760	150	05/19/2003	ANALYSIS OF SEMICONDUCTOR SURFACES BY SECONDARY ION MASS SPECTROMETRY AND METHODS	MARSH, EUGENE P.
10637362	Not Issued	161		Atomic layer deposition of metal during the formation of a semiconductor device	MARSH, EUGENE P.
10639409	6900107	150	08/12/2003	DEVICES CONTAINING PLATINUM- IRIDIUM FILMS AND METHODS OF PREPARING SUCH FILMS AND DEVICES	MARSH, EUGENE P.
10642454	Not Issued	41		Platinum-containing integrated circuits and capacitor constructions	MARSH, EUGENE P.
10643680	Not Issued	30		Atomic layer deposition methods of forming conductive metal nitride comprising layers	MARSH, EUGENE P.
10657069	Not Issued	80	09/09/2003	Capacitor with rhodium electrode	MARSH, EUGENE P.
10680038	6946395	150	II I	DEVICES CONTAINING ZIRCONIUM- PLATINUM-CONTAINING MATERIALS AND METHODS FOR PREPARING SUCH MATERIALS AND DEVICES	MARSH, EUGENE P.
10741256	Not Issued	93		METHODS OF FORMING ROUGHENED LAYERS OF PLATINUM	MARSH, EUGENE P.
10755097	Not Issued	71		Methods and apparatus for forming rhodium-containing layers	MARSH, EUGENE P.
10840535	Not Issued	30	05/06/2004	Selective provision of a diblock copolymer material	MARSH, EUGENE P.
10848321	Not Issued	41	05/18/2004	Method of forming a conductive structure	MARSH, EUGENE P.
10848985	Not Issued	41	05/18/2004	Surface treatment of an oxide layer to enhance adhesion of a ruthenium metal layer	MARSH, EUGENE P.
10910219	Not Issued	41		Method of forming metal oxide and semimetal oxide	MARSH, EUGENE P.

10012006			100/06/2004		MADOU ELICENE D
10912906	Not Issued	61	08/06/2004	Devices containing platinum-iridium films and methods of preparing such films and devices	MARSH, EUGENE P.
10914888	Not Issued	71	08/09/2004	Dielectric material forming methods and enhanced dielectric materials	MARSH, EUGENE P.
10923478	Not Issued	61	08/20/2004	Systems and methods for the electrolytic removal of metals from substrates	MARSH, EUGENE P.
10929633	Not Issued	30	08/30/2004	Platinum stuffed with silicon oxide as a diffusion oxygen barrier for semiconductor devices	MARSH, EUGENE P.
10932149	Not Issued	30	09/01/2004	Deposition methods using heteroleptic precursors	MARSH, EUGENE P.
11039564	Not Issued	41	01/19/2005	Nucleation method for atomic layer deposition of cobalt on bare silicon during the formation of a semiconductor device	MARSH, EUGENE P.
11053798	Not Issued	30	02/09/2005	Metal plating using seed film	MARSH, EUGENE P.
11054018	Not Issued	71	02/09/2005	Metal plating using seed film	MARSH, EUGENE P.
11063740	Not Issued	160	02/24/2005	Process for direct deposition of ALD RhO2	MARSH, EUGENE P.
11105148	Not Issued	30	04/12/2005	Method of forming a catalytic surface comprising at least one of Pt, Pd, Co and Au in at least one of elemental and alloy forms	MARSH, EUGENE P.
11134906	Not Issued	30	05/23/2005	Process for forming a low carbon, low resistance metal film during the manufacture of a semiconductor device and systems including same	MARSH, EUGENE P.
11167074	Not Issued	30	06/27/2005	Nucleation and deposition of platinum group metal films using ultraviolet irradiation	MARSH, EUGENE P.
11185423	Not Issued	20	07/20/2005	ALD formed titanium nitride films	MARSH, EUGENE P.
11197184	Not Issued	30	08/04/2005	Conductive nanoparticles	MARSH, EUGENE P.
11212899	Not Issued	20	08/26/2005	Semiconductor structures	MARSH, EUGENE P.
11215569	Not Issued	30		Devices containing zirconium-platinum- containing materials and methods for preparing such materials and devices	MARSH, EUGENE P.
11217982	Not Issued	20		Porous organosilicate layers, and vapor deposition systems and methods for preparing same	MARSH, EUGENE P.

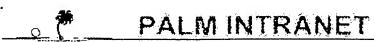
11233967	Not Issued	30	E i	Methods of forming metal oxide and semimetal oxide	MARSH, EUGENE P.
08879747	6051287	150	06/20/1997	LASER DESORPTION OF CVD PRECURSOR	MARSH, EUGENE P.
09035197	5920068	150		ANALYSIS OF SEMICONDUCTOR SURFACES BY SECONDARY ION MASS SPECTROMETRY	MARSH, EUGENE P.
<u>09140878</u>	6074945	150		METHODS FOR PREPARING RUTHENIUM METAL FILMS	MARSH, EUGENE P.
09140921	Not Issued	161	08/26/1998	CVD PLATINUM-RHODIUM BARRIER LAYER	MARSH, EUGENE P.
09140932	6133159	150		METHODS FOR PREPARING RUTHENIUM OXIDE FILMS	MARSH, EUGENE P.

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Application#	Patent#	Status	Date Filed	Title	Inventor Name			
09141240	6197628	150	08/27/1998	RUTHENIUM SILICIDE DIFFUSION BARRIER LAYERS AND METHODS OF FORMING SAME	MARSH, EUGENE P.			
09141840	6583022	150	08/27/1998	METHODS OF FORMING ROUGHENED LAYERS OF PLATINUM AND METHODS OF FORMING CAPACITORS	MARSH, EUGENE P.			
<u>09146292</u>	6261850	150	09/03/1998	DIRECT WRITING OF LOW CARBON CONDUCTIVE MATERIAL	MARSH, EUGENE P.			
09146297	6284655	150	09/03/1998	METHOD FOR PRODUCING LOW CARBON/OXYGEN CONDUCTIVE LAYERS	MARSH, EUGENE P.			
09146300	6204172	150	09/03/1998	LOW TEMPERATURE DEPOSITION OF BARRIER LAYERS	MARSH, EUGENE P.			
<u>09146408</u>	6218297	150	09/03/1998	METHOD OF PATTERNING METAL LAYERS BY ANNEALING A METAL LAYER FORMED OVER A PATTERNED METAL-CONTAINING ADHESION LAYER	MARSH, EUGENE P.			
<u>09146866</u>	6323081	150		DIFFUSION BARRIER LAYERS AND METHODS OF FORMING SAME	MARSH, EUGENE P.			
09177019	6218316	150	10/22/1998	PLANARIZATION OF NON-PLANAR SURFACES IN DEVICE FABRICATION	MARSH, EUGENE P.			
09221861	6204178	150		NUCLEATION AND DEPOSITION OF PT FILMS USING ULTRAVIOLET IRRADIATION	MARSH, EUGENE P.			
09259209	6421223	150		THIN FILM STRUCTURE THAT MAY BE USED WITH AN ADHESION LAYER	MARSH, EUGENE P.			
09281735	5990559	150		CIRCUITRY COMPRISING ROUGHENED PLATINUM LAYERS, PLATINUM-CONTAINING MATERIALS, CAPACITORS	MARSH, EUGENE P.			

				COMPRISING ROUGHENED PLATINUM LAYERS, METHODS OF FORMING ROUGHENED LAYERS OF PLATINUM, AND METHODS OF FORMING CAPACITORS	
09309208	6232600	150		ANALYSIS OF SEMICONDUCTOR SURFACES BY SECONDARY ION MASS SPECTROMETRY	MARSH, EUGENE P.
09340985	6143667	150	06/28/1999	METHOD AND APPARATUS FOR USING PHOTOEMISSION TO DETERMINE THE ENDPOINT OF AN ETCH PROCESS	MARSH, EUGENE P.
09352817	6318381	150	li l	METHODS OF CLEANING VAPORIZATION SURFACES	MARSH, EUGENE P.
09382042	6323511	150	08/24/1999	STRUCTURES INCLUDING LOW CARBON/OXYGEN CONDUCTIVE LAYERS	MARSH, EUGENE P.
<u>09386976</u>	6265722	150	11	ORGANIC FIELD IONIZATION SOURCE	MARSH, EUGENE P.
09399591	6281161	150	ii i	PLATINUM -CONTAINING MATERIALS AND CATALYSTS	MARSH, EUGENE P.
<u>09421625</u>	Not Issued	93		CIRCUITRY AND CAPACITORS COMPRISING ROUGHENED PLATINUM LAYERS	MARSH, EUGENE P.

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